



**ELECTRONIC COPY**

LG768699651  
Report verification at igi.org



January 24, 2026  
IGI Report Number **LG768699651**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **9.87 X 7.10 X 4.52 MM**  
**GRADING RESULTS**  
Carat Weight **2.02 CARATS**  
Color Grade **F**  
Clarity Grade **VS 2**

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**GRADING RESULTS**

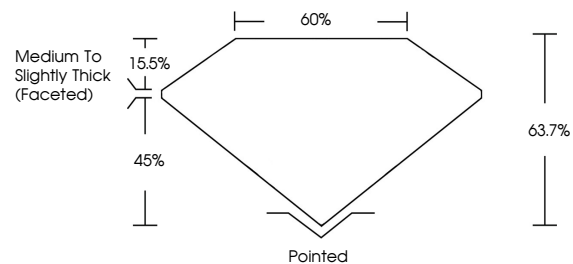
Carat Weight **2.02 CARATS**  
Color Grade **F**  
Clarity Grade **VS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG768699651**

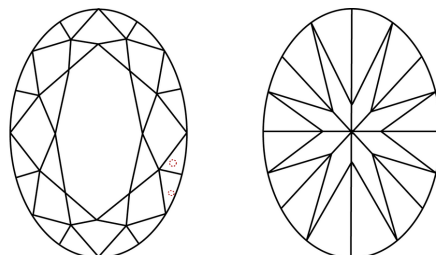
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

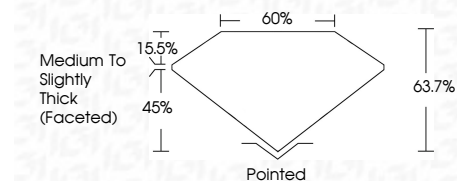
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**OVAL BRILLIANT**  
9.87 X 7.10 X 4.52 MM  
2.02 CARATS  
F  
Color Grade  
VS 2  
Clarity Grade  
63.7%  
45%  
Table  
Girdle  
Medium to Slightly Thick (Faceted)  
Pointed  
Culet  
EXCELLENT  
Polish  
EXCELLENT  
Symmetry  
NONE  
Fluorescence  
IGI LG768699651  
Inscription(s)

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